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# **Programmable Gas Analyser**



Capable of measuring almost any combination of gases; hydrogen, helium, oxygen, carbon dioxide, methane, carbon monoxide, argon, nitrogen and many others.





# **Applications**

Gas Mixing

Welding Gases

**Heat Treatment Atmospheres** 

Hydrogen/Helium Purity

Food Packaging Gases

## Features & Benefits

- Programmable for different gases
- **Built-in linearisation**
- Fast response
- **Excellent stability**
- Built-in alarms and analogue outputs

- Diagnostics
- Insensitive to sample flow
- Computer communications
- Autoranging electronics
- Built-in auto-calibration

The 542 is a versatile, programmable gas analyser, based on the principles of thermal conductivity, capable of measuring almost any combination of gases. The instrument is especially suitable for measurements of mixtures containing hydrogen or helium.

With the use of sensitive floating circuits, the thermal conductivity analyser can detect gases down to parts per million levels and up to full concentration. The analyser is pre-programmed for a wide range of sample and reference gases, easily selectable from the simple front panel menu.

Calibration settings, for each combination of gases used, are stored in an internal memory and are recalled automatically every time a particular gas mix is required. This enables quick and easy switching between gas combinations.

Sophisticated microprocessor electronics enable the fastest possible response time, excellent stability and flexibility. Sample pressure and flow are internally controlled allowing connection to a wide range of pressurised samples. Automatic calibration is included as standard, when the instrument can be set to perform a zero and span calibration at timed intervals.

### **Principle of Operation**

All gases conduct heat at a specific rate. known as the thermal conductivity of the gas. Matched pairs of heated filaments are installed in a large thermal mass detection block, one set in the stable reference gas and the other in the measured sample gas.

Each of these detectors form part of a Wheatstone Bridge powered by a constant current source.

When the measured gas concentration changes, the sample detector will detect a change in the thermal conductivity and will cause an imbalance in the Wheatstone Bridge, resulting in a signal output proportional to the change in gas concentration. The signal is processed by state of the art digital electronics and the results shown on a high resolution digital LED display.

#### **Technical Specifications**

Dependent on selected gas mix. Adjustable, auto-ranging. Typical: 0-1000ppm ( $H_2$  in  $N_2$ ) 98-100% ( $O_2$  in Ar) Ranges

Resolution ± 2% of scale\* Accuracy

Response Time 90% of reading in 20 seconds Calibration Range 0-100% of selected measure gas.

Automatic timed calibration as standard. Auto zero.

Measuring Cell Type Thermal conductivity/katherometer, ultra stable

Alarms Two adjustable alarms with volt-free, change-over contacts

Fully configurable over complete range. Contact rating 10A at 240V ac/30V dc

**Analogue Outputs** 0-10V, 4-20mA (both isolated). Max loop resistance 500 Ohms

Serial Interface Allows connection to a computer

**Operating Conditions** 

Sample Inlet Pressure 1.0 to 7.0 Barg

Internally controlled (max 250ml/min) Sample Flow Rate

-10 to 40°C Sample temperature **Ambient Temperature** -5 to 50°C

Sample Connections 1/8" OD compression fittings (others on request) Unsuitable gases Corrosive gases (contact factory for alternatives)

**Power Requirements** 

**Power Supply** 230/115V ± 10%, 50/60Hz at 40VA

Display Type 4 digit high visibility LED and 12 digit alphanumeric

Cabinetry and Mounting

**Enclosure** Sheet steel

Installation Bench or panel mounting (3U - 19" rack)

535W x 165H x 300D (mm) panel cutout 445W x 132.5D (mm) **Dimensions** 

Weight 12kg Ingress Protection **IP40** 

**Options** 

Sample Gas Pump Externally mounted

IP55 Enclosure

Sealed Reference Gas Dependent on application and range (contact Systech for options) **Corrosive Gases** Contact Systech Illinois for information on alternative options.

\*Note: The 542 can be used to measure over 400 gas combinations. Some gas combinations can be measured in ppm but others can only be measured in percent levels therefore please contact the sales department for typical values. The accuracy of the instrument will be ± 2% of scale of the stated typical value.

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